

10/567173

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Appl. No. : Unassigned Confirmation No. Unassigned
First Inventor : AMATO, Joseph M.
Filed : Concurrently
TC/A.U. : Unassigned
Examiner : Unassigned

Docket No. : US03 0199 US2
Customer No. : 24738

Title: Offset Dependent Resistor for Measuring Misalignment of
Stitched Masks

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to calculation of the filing fee and examination please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.